

DIAGNOSIS METHOD AND DIAGNOSIS SYSTEM FOR
MONITORING THE AVAILABLE RESOURCES
IN A PRODUCTION PROCESS
DAFERNER, et al.
PCT No.: PCT/EP00/0500
Attorney Docket No. 225/50818
Sheet 1 of 3

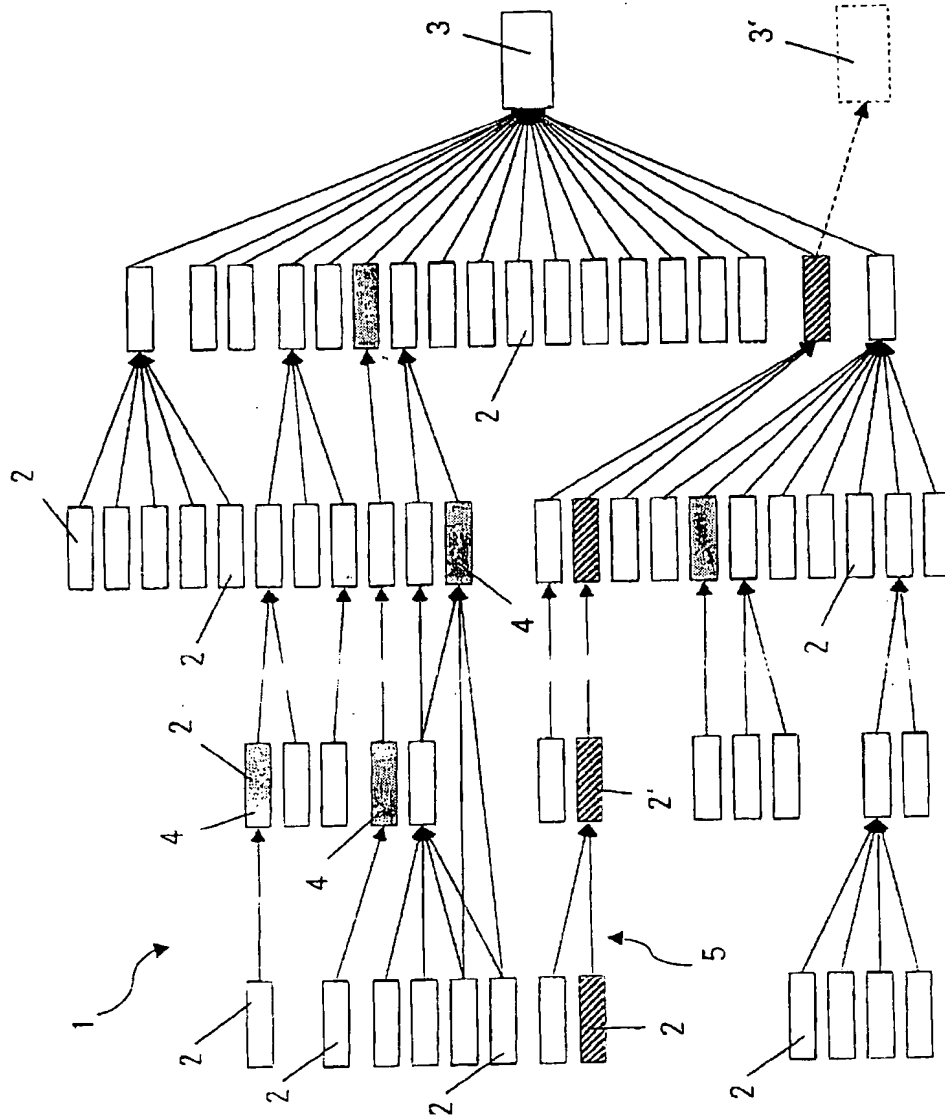


Figure 1

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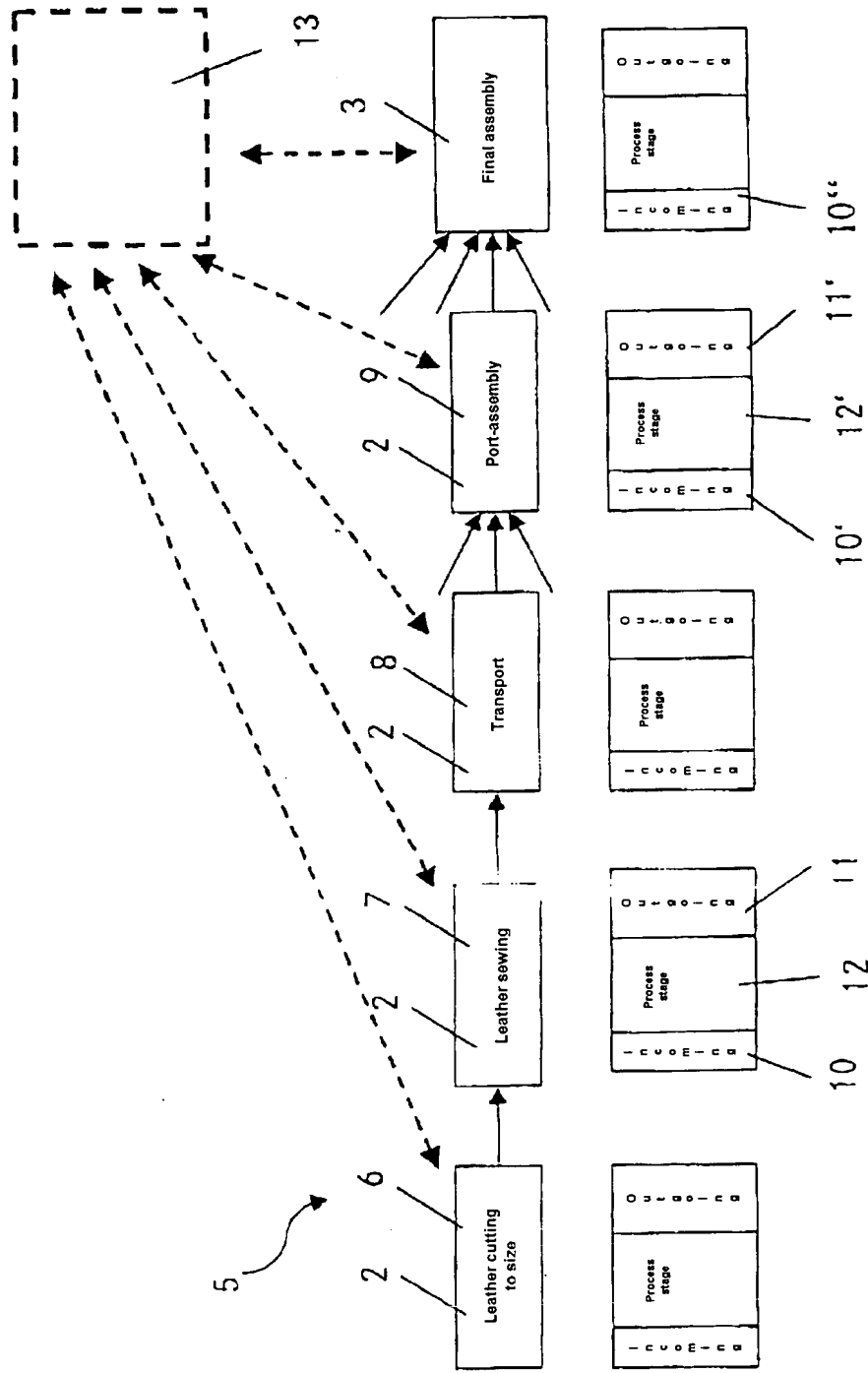


Figure 2

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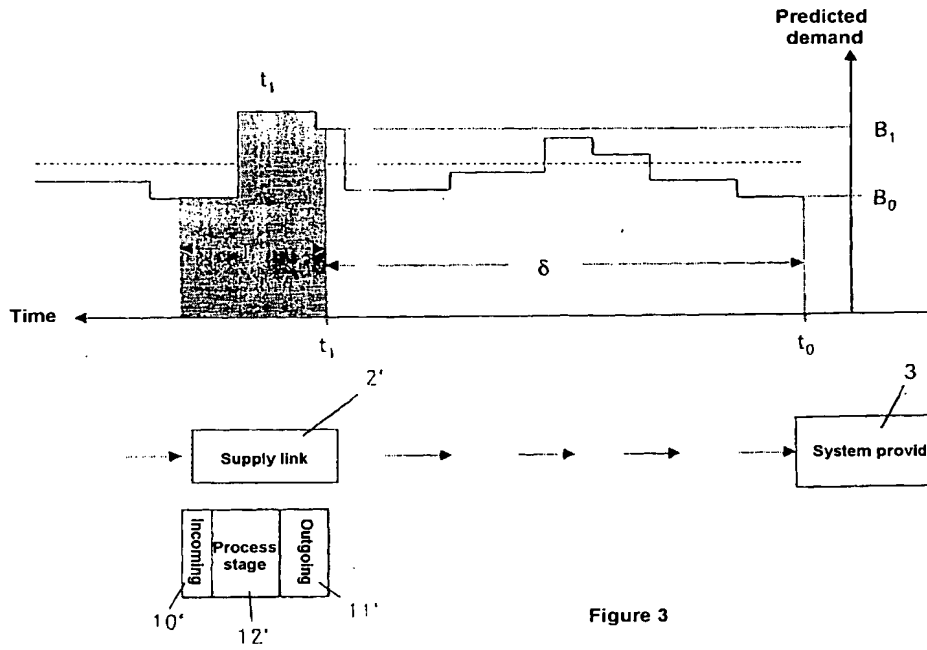


Figure 3